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	Application No.	Applicant(s)	
Notice of Allowability	09/819,690	TAKANO, SATOSHI	
	Examiner	Art Unit	
	Granvill D Lee, Jr	2825	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOT THE OFFICE OF UPON PETITION BY THE OFFICE OFFI	OR REMAINS) CLOSED in the or other appropriate communing GHTS. This application is subsected in the community of the communit	nis application. If not included cation will be mailed in due co	urse. THIS
1. This communication is responsive to <u>1/5/04</u> .			
2. \boxtimes The allowed claim(s) is/are <u>1-6 and 9-19</u> .			
3. $igotimes$ The drawings filed on 29 March 2001 are accepted by the E	Examiner.		
4. Acknowledgment is made of a claim for foreign priority unital all all block opies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 1. Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give (a) including changes required by the Notice of Draftsperson 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.1 each sheet. Replacement sheet(s) should be labeled as such in the paper No./Mail Date DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F	been received. been received in Application furnishments have been received in Suments application. Suments of this application. Suments of the attached EXAM is reason(s) why the oath or distributed in Suments of Sument	No In this national stage application reply complying with the requirement of the requirement of the Office action of the United States of the Office action of the States of t	rements FICE OF
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Sum Paper No./Ma 3), 7. ☐ Examiner's Ar	mal Patent Application (PTO-1 mary (PTO-413), ail Date nendment/Comment atement of Reasons for Allowa	·

DETAILED ACTION

Response to RCE/Amendment

The RCE/amendment filed on 1/5/04 has been received and acknowledged to be found persuasive in view of the prior art of record.

Allowable Subject Matter

Claims 1-6 and 9-19 are allowed.

Reasons for Allowance

The following is an examiner's statement of reasons for allowance: The prior art of record does not describe or suggest a continuous inert gas flow into a chamber during all wafer transfers into subsequent chambers as claimed. The claims, therefore define over the prior art. Any comments considered necessary by applicant must be submitted no later than the payments of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Contact Information

Any inquiry concerning this communication or earlier communications for the examiner should be directed to Granvill Lee whose telephone number is (571) 272-1897. The examiner can be normally reached on Monday thru Thursday from 7:00 am to 5:30 pm.

If attempts to reach the examiner by telephone are not successful, the examiner's supervisor, Matthew Smith can be reached on (571) 272Application/Control Number: 09/819,690

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1907. The fax phone number for this group is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Examiner Granvill Lee Art Unit 2825

Gl 3/21/04

> MATTHEW SMITH SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800